



Attorney Docket: 081468-0308363  
Client Reference: P-1518.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:  
VAN GROOS, ET AL.

Confirmation Number: 3926

Application No.: 10/797,657

Group Art Unit: 2851

Filed: March 11, 2004

Examiner: Kim, Peter B.

Title: LITHOGRAPHIC PROJECTION ASSEMBLY, SUBSTRATE HANDLING  
APPARATUS AND SUBSTRATE HANDLING METHOD

**COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Notice of Allowance dated June 23, 2006, consideration of the following comments are respectfully requested.

In the Notice of Allowability, the Examiner has set forth "Reasons for Allowance." The Applicants respectfully traverse these Reasons. Specifically, it is submitted that the subject matter of the allowed claims are patentable for their respective recitations of claimed combinations as a whole, without any particular criticality or distinguishing feature being attributable to any one or more of such features, and without any narrowing interpretation being imposed on any of such features.

Respectfully submitted,

PILLSBURY WINTHROP SHAW PITTMAN LLP

E. R. HERNANDEZ  
Reg. No. 47641  
Tel. No. 703.770.7788

Date:  
P.O. Box 10500  
McLean, VA 22102  
(703) 770-7900